



3742/41

Attorney Docket No. 0756-2412

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI

Serial No. 10/021,708

Filed: December 19, 2001

For: HEAT TREATMENT APPARATUS
AND METHOD OF
MANUFACTURING A
SEMICONDUCTOR DEVICE

) Group Art Unit: 3742

) Examiner: S. Fuqua

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
) being deposited with the United States Postal
) Service with sufficient postage as First Class
) Mail in an envelope addressed to:
) Commissioner for Patents, P.O. Box 1450,
) Alexandria, VA 22313-1450, on

6-15-04

Adeline M. Stamps

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED

JUN 23 2004

TECHNOLOGY CENTER R3700

Sir:

In response to the Official Action dated January 15, 2004, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 26 of this paper.